



Attorney's Docket No.: 10417-084001 / F51-134741M/SW

2815
JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Izuo Iida
Serial No. : 09/876,554
Filed : June 7, 2001
Title : METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

Art Unit : 2815
Examiner : N. Drew Richards

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF APRIL 28, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

July 28, 2004

Date of Deposit

Signature

PATRICIA F. SUCHANEK

Typed or Printed Name of Person Signing Certificate